

<b>Search Notes</b> 	<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>
	10/628,253	KIM ET AL.
	<b>Examiner</b>	<b>Art Unit</b>
	Satya B. Sastri	1713

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
524	492	7/18/07	~
	433	↓	↓
	436	↓	↓
	560	↓	↓

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
East Inventorship NPL	7/3/06	~
STLC 524 /4-92; v50 &; 427 /428.1 CCIS.	↓	↓
with key word.		
Updated search	12/6/06	~
"	7/18/07	~